



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**PATENT**

In re application of: Kapre, et al

Attorney Docket No.: 01-721RCE/  
LSI1P185

Application No.: 10/020,304

Examiner: Sefer, Ahmed N.

Filed: December 13, 2001

Group: 2826

**Title: BURIED CHANNEL DEVICES AND A  
PROCESS FOR THEIR FABRICATION  
SIMULTANEOUSLY WITH SURFACE  
CHANNEL DEVICES TO PRODUCE  
TRANSISTORS AND CAPACITORS WITH  
MULTIPLE ELECTRICAL GATE OXIDES**

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on October 31, 2003 in an envelope addressed to the Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

Mia Mitchell-Hayes

**Amendment D**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The enclosed remarks are submitted in response to the Office Action mailed on August 14, 2003. Applicants respectfully request reconsideration of the captioned application in view of the following remarks and amendments. A listing of the claims and amendments commences on page 2. Remarks begin on page 5 of this paper.

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